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Sut	Substitute for form 1449A/PTO			Complete if Known			
				Application Number	09/536,861		
SUPPLEMENTAL INFORMATION			Filing Date	March 27, 2000			
	DISCLOSURE STATEMENT BY APPLICANT			First Named Inventor	Tibor Juhasz	RECEIVED	
l s				Art Unit	3739		
					Examiner Name	D. M. Shay	MAR 2 2 2004
Sheet	1	·	of	2	Attorney Docket Number	HO-P02276UF	HNOLOGY CENTER R37

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		Document Number	Publication Date		Pages, Columns, Lines,		
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Initials*	No.1	Country Code ³ -Number ⁴ -Kind Code ⁶ (if known)	MM-DD-YYYY	Applicant of Cited Document	Passages or Relevant Figures Appear	T	
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Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵Kind of document by the appropriate symbols as Indicated on the document under WIPO Standard ST. 18 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
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First Named Inventor	Tibor Juhasz	RECEIVE
Art Unit	3739	
Examiner Name	D. M. Shay	MAR 2.2 2004
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	Filling Date First Named Inventor Art Unit Examiner Name	Application Number 09/536,861 Filling Date March 27, 2000 First Named Inventor Tibor Juhasz Art Unit 3739 Examiner Name D. M. Shay

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Examiner Date Signature Considered

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er the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Complete if Known ubstitute for form 1449A/PTO Application Number 09/536,861 INFORMATION DISCLOSURE **Filing Date** March 27, 2000 STATEMENT BY APPLICANT First Named Inventor Tibor Juhasz 3739 Art Unit (use as many sheets as necessary) Examiner Name D. M. Shay Sheet 4 1 HO-P02276US1 Attorney Docket Number

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	FOREIGN PATENT DOCUMENTS							
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	NON PATENT LITERATURE DOCUMENTS				
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